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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	Not Assigned 10/826602	
			Filing Date	Herewith	
			First Named Inventor	Yeo, et al.	
			Art Unit	TBD 1756	
			Examiner Name	TBD Raymond, Brittany	
Sheet	1	of	1	Attorney Docket Number	TSM03-0847

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
BR ↓ ↓ ↓ ↓ ↓ BR	A	US-4,348,164	08-24-1982	Tarbarelli, et al.	
	B	US-4,480,910	11-08-1984	Takanashi, et al.	
	C	US-4,509,852	04-09-1985	Tabarelli, et al.	
	D	US-5,121,256	08-09-1992	Corle, et al.	
	E	US-5,610,683	03-11-1997	Takahashi	
	F	US-5,900,354	05-04-1999	Batchelder	
	G	US-2002/0163629 A1	11-07-2002	Switkes, et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
BR	H	HOFFNAGLE, J.A., et al., "Liquid Immersion Deep-Ultraviolet Interferometric Lithography," J. Vacuum Science and Technology B, 1999 American Vacuum Society, Vol. 17, No. 6, pp. 3306-3309, Nov/Dec 1999.	
BR	I	SWITKES, M., et al., "Immersion Lithography at 157 nm, J. Vacuum Science and Technology B, 2001 American Vacuum Society, Vol. 19, No. 6, pp. 2353-2356, Nov/Dec 2001.	

Examiner Signature	Brittany Raymond	Date Considered	4/27/2007
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